

INFORMATION DISCLOSURE STATEMENT				Page <u>1</u> Of <u>1</u>				
				Atty. Docket No. FUK-12CPA		Serial No.		
				Applicant Migaku Takahashi				
				Filing Date September 18, 2003		Group 1753		
U.S. PATENT DOCUMENTS								
Examiner Initial *		Document No.	Date	Name	Class	Subclass	Filing Date	
<i>[Signature]</i>	AA	5,736,264	7/98	Ishiwata et al.	G11B	5/66	3/93	
	AB	5,382,305	1/95	Terunuma et al.	H01F	10/00	8/93	
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	AD	5,465,475	11/95	Kinoshita et al.	G11B	5/42	7/93	
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		Document No.	Date	Country	Class	Subclass	Translation	
							Yes	No
<i>[Signature]</i>	AM	59-45911	3/84	Japan	C01B	21/06	3/82	
	AN	62-164868	7/87	Japan	C23C	14/06	1/86	
	AO	2-212320	8/90	Japan	C01G	49/00	2/89	
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OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)								
<i>[Signature]</i>	AT	Journal of Applied Physics 53 (11), November 1982. Pp. 8332-8334. "Metastable Fe Nitrides with High Bs Prepared by Reactive Sputtering". A. KANO, N.S. KAZAMA, H. FUJIMORI						
EXAMINER: <i>[Signature]</i>				DATE CONSIDERED: <i>7/14/05</i>				
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								